



7-8-03

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SAM435-100/00656 Customer No.24,118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: DONG-ILL CHO )  
SERIAL NO: 09/614,785 )  
FILED: 07/12/2000 )  
FOR: SILICON ETCHING APPARATUS USING )  
XeF2 )  
ART UNIT: 1746 )  
EXAMINER: PARVIZ HASSANZADEH )

RECEIVED  
JUL 10 2003  
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#11 ONE  
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AMENDMENT

Mail Stop Non-Fees  
Commission for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated 4/7/2003, the Applicant requests the above-identified application to be re-examined in view of the following amendments and remarks:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Director of Patents, PO Box 1450, Alexandria, VA 22313-1450, on 3 July 2003

*[Signature]*